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JUN 22 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No..... 10/620,468
 Filing Date July 15, 2003
 Inventor Dinesh Chopra
 Assignee Micron Technology, Inc.
 Group Art Unit 2822
 Examiner T. Tran
 Attorney's Docket No. MI22-2345
 Title: Conductive Connection Forming Methods, Oxidation Reducing Methods,
 and Integrated Circuits Formed Thereby

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

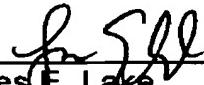
The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 22 Jun 2005

By:


 James E. Lake
 Reg. No. 44,854

06/24/2005 MBINAS 00000020 230925 10620468
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2345	SERIAL NO. 10/620,468	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: Dinesh Chopra				
		FILING DATE July 15, 2003		GROUP 2822		
U.S. PATENT DOCUMENTS						
*Examiner's Initials		Document Number	Date	Name	Class	Subclass
						Filing Date If Appropriate
AA	6,172,421	01/2001	Besser et al.	257	751	
AB	6,444,567	09/2002	Besser	438	625	
AC						
AD						
AE						
AF						
AG						
AH						
AI						
FOREIGN PATENT DOCUMENTS						
		Document Number	Date	Country	Class	Subclass
						Translation
AJ						Yes
AK						No
AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
AM						
AN						
AO						
EXAMINER		DATE CONSIDERED				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>						